



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 1393

Takashi TANAKA ET AL. : Docket No. 2001\_1507A

Serial No. 09/970,621 : Group Art Unit 3723

Filed October 5, 2001 : Examiner Lee D. Wilson

METHOD FOR SUPPLYING SLURRY  
TO POLISHING APPARATUS

---

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed January 14, 2004, please amend the above-identified application as follows:

RECEIVED  
APR 14 2004  
TECHNOLOGY CENTER R3700

04/08/2004 KBETEMA1 00000007 09970621

01 FC:1201

258.00 OP